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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Range IRADE IRAD

Filed: October 17, 2001

Title: Semiconductor Device and Method

for Its Manufacture

Attorney Docket No.: N320402-00W

Group Art Unit: 2815

Examiner: Richards, N. D.

## AMENDMENT AFTER FINAL ACTION (37 C.F.R. §1.116)

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313

## A. Introductory Comments

The following is submitted in response to the FINAL Office Action dated <u>June 2</u>, <u>2004</u>, and is currently due <u>October 4, 2004</u> with a 1-month extention.

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	37 C.F.R. §1.8
5	I hereby certify that this correspondence is being
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	Date of Deposit:September 27, 2004
5	Typed/Printed Name:Darryl Walker